

Influence of substrate and film thickness on polymer LIPSS formation

Jing Cui¹, Aurora Nogales¹, Tiberio A. Ezquerra¹, Esther Rebollar^{2}*

¹Instituto de Estructura de la Materia (IEM-CSIC), Serrano 121, Madrid, 28006.Spain

²Instituto de Química Física Rocasolano (IQFR-CSIC), Serrano 119, Madrid, 28006. Spain

*Corresponding author: e.rebollar@csic.es

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